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Substitute for form 1449A/PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Application Number	10/060,922
(use as many sheets as necessary)		Filing Date	January 29, 2002
		First Named Inventor	Peter R. David
		Group Art Unit	1765
		Examiner Name	Robert M. Kunemund
Sheet	1	of	1
		Attorney Docket Number	SYRTECH-5002-C9

U.S. PATENT DOCUMENTS

Examiner Initials *	Cite No. ³	Document Number	Publication Date/ Filing Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
	AA	US- 5,833,860	11-10-1998	Kopaclewicz et al.	
	AB	US- 6,220,075	04-24-2001	Papen et al.	
	AC	US- 2002/0137218-A1	09-26-2002	Mian et al.	
	AD	US- 2002/0189530-A1	12-19-2002	David	
	AE	US- 2002/0195047-A1	12-26-2002	David	
	AF	US- 2002/0195051-A1	12-26-2002	David	
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	AH	US- 6,527,432	03-04-2003	Kellogg et al.	
	AI	US- 2003/0154910-A1	08-21-2003	David	

FOREIGN PATENT DOCUMENTS

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

CITED DOCUMENTS - NON-PATENT LITERATURE DOCUMENTS				
Examiner Initials /	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
/	AU	Sanjoh et al., "Spatiotemporal protein crystal growth studies using microfluidic silicon devices". Journal of Crystal Growth Vol. 158 (1995) pages 691-702.		T ²

Examiner Signature		Date Considered	1/24/04
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